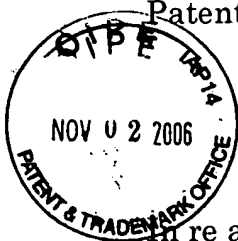


ZFW

Patent Application No. 10/599,544

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Youhei SAKAI

Serial No: 10/599,544

Filed: September 29, 2006

For: SILICON CASTING APPARATUS AND  
METHOD OF PRODUCING SILICON  
INGOT

Art Unit: Not assigned

Examiner: Not assigned

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**SECOND PRELIMINARY AMENDMENT**

MAIL STOP AMENDMENT

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Dear Sir:

Prior to the first Office Action in the present application, please enter and  
consider the following amendments and remarks:

**Amendments** to the specification begin on page 2 of this paper.

**Remarks/Arguments** begin on page 3 of this paper.